

Electronic Supplementary Information (EIS)

Reduced fibrous capsule formation at nano-engineered silicone surfaces via tantalum ion implantation

Cheonil Park^{a,†}, Si-Woo Lee^{b,†}, Jinyoung Kim^a, Eun-Ho Song^a, Hyun-Do Jung^c, Ji-Ung Park^d

Hyoun-Ee Kim^a, Sukwha Kim^{b,*}, and Tae-Sik Jang^{c,*}

^a Department of Materials Science and Engineering, Seoul National University, Seoul, 08826, Korea

^b Department of Plastic and Reconstructive Surgery, Seoul National University College of Medicine, Seoul, 03080, Korea

^c Research Institute of Advanced Manufacturing Technology, Korea Institute of Industrial Technology, Incheon, 21999, Korea

^d Department of Plastic and Reconstructive Surgery, Seoul National University Boramae Medical Center, Seoul, 07061, Korea

[†]Both authors contributed equally to this work

Co-Corresponding author.

E-mail address: cgamja@snu.ac.kr (T.S. Jang) / kimsw@snu.ac.kr (S. Kim)

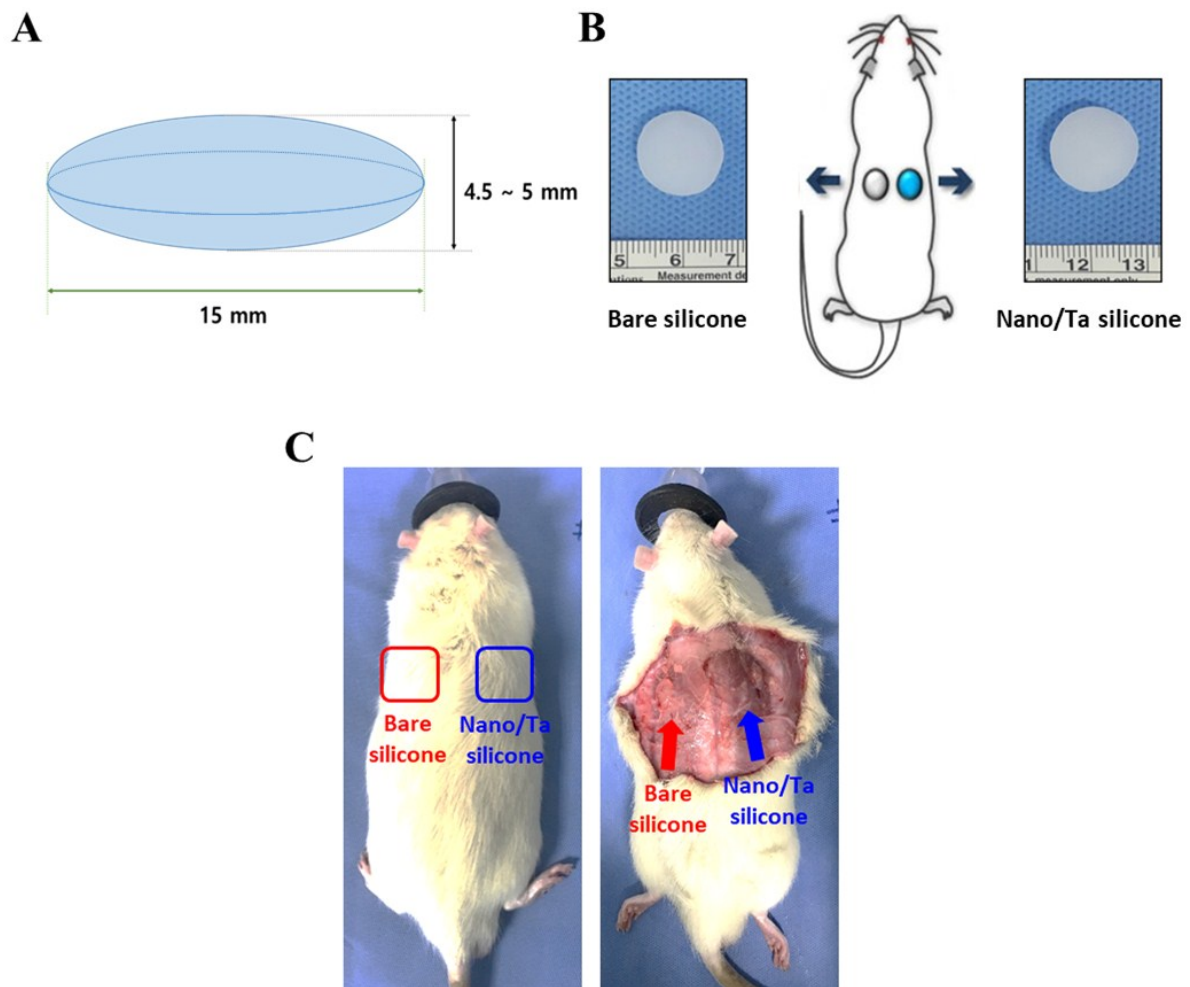


Fig. S1. (A) Schematic illustration of the silicone implant and its dimensions used in the *in vivo* animal test. (B) *In vivo* mouse dorsal implantation model. (C) Optical views of the implanted bare and Nano/Ta silicone samples after 8 weeks of surgery.

Table S1a. Mean- and maximum-height surface roughnesses (R_a and R_z) for the three types of silicone implants.

Surface roughness	Bare silicone	Smooth/Ta silicone	Nano/Ta silicone
R_a (nm)	17 ± 4	21 ± 7	67 ± 6
R_z (nm)	87 ± 16	91 ± 23	368 ± 34

Table S1b. Mean- and maximum-height surface roughnesses (R_a and R_z) of Smooth/Ta and Nano/Ta silicone after 28 days of immersion in PBS.

Surface roughness	Smooth/Ta silicone	Nano/Ta silicone
R_a (nm)	25 ± 8	65 ± 7
R_z (nm)	144 ± 5	404 ± 35

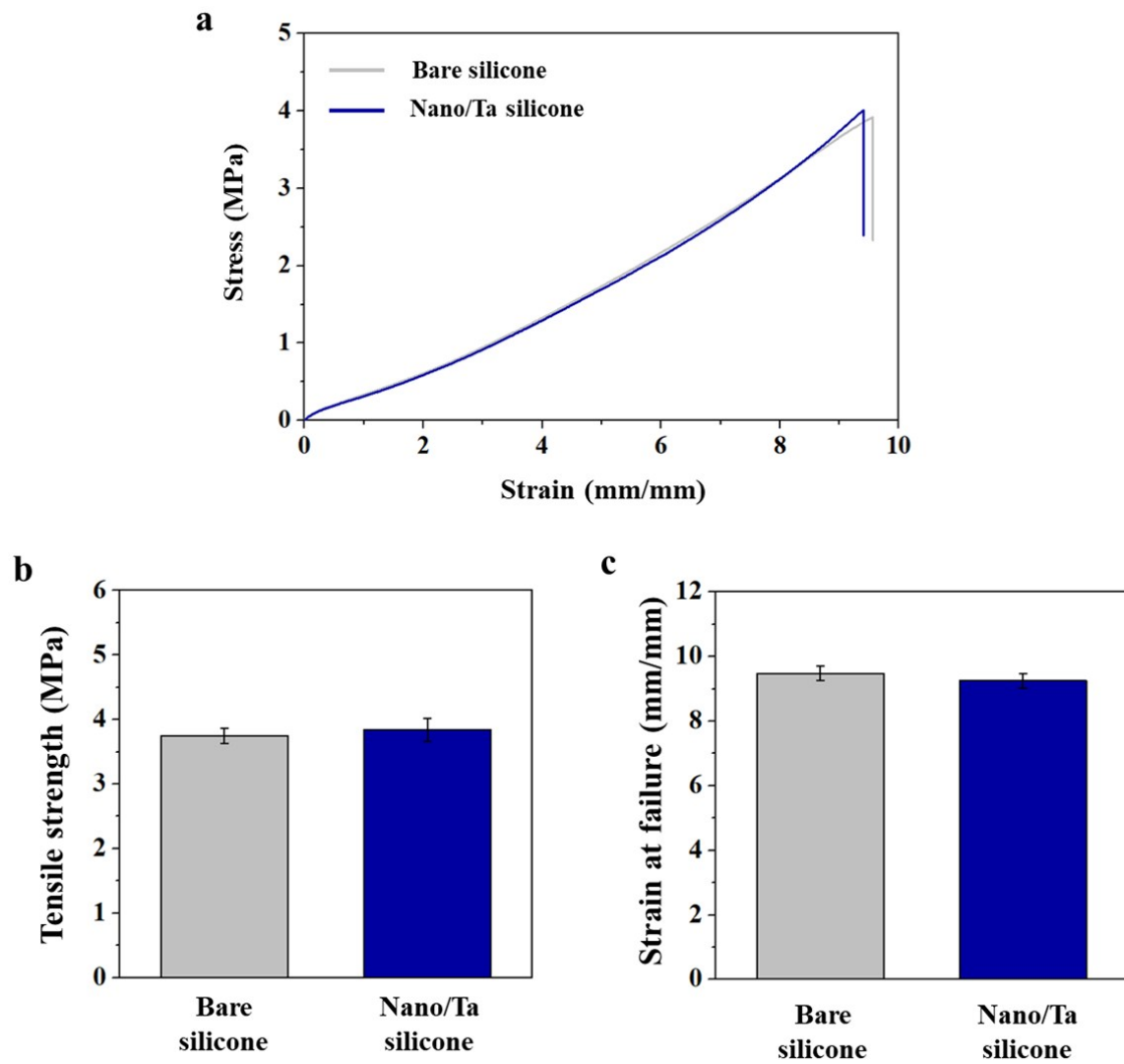


Fig. S2. (a) Stress–strain curve, (b) tensile strength, and (c) strain at failure of bare and Nano/Ta silicone implants.

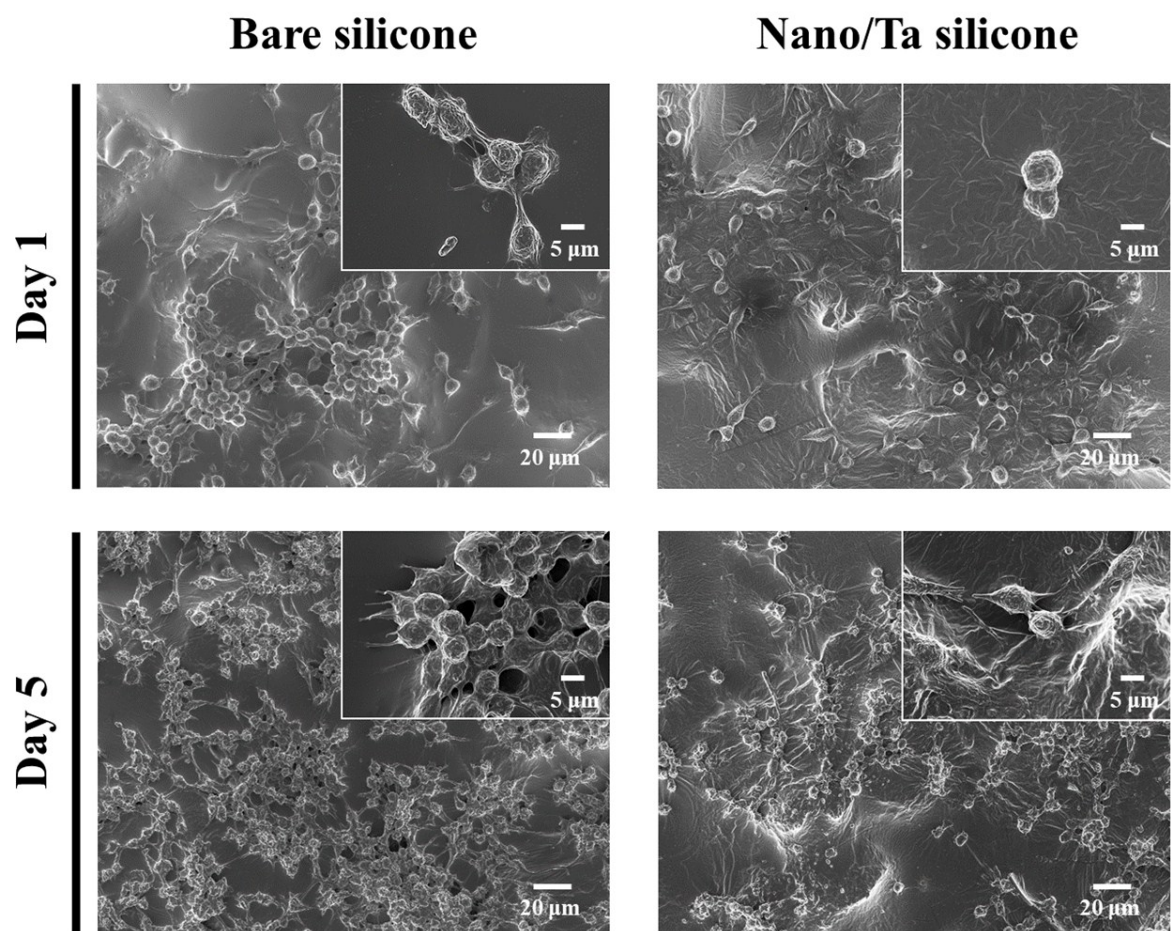


Fig. S3. FE-SEM images of adhered macrophages on the surfaces of bare and Nano/Ta silicone implants after 1 and 5 days of culturing. Insets are magnified views of the macrophages.